

# PATENT ABSTRACTS OF JAPAN

(11)Publication number : 04-073928

(43)Date of publication of application : 09.03.1992

(51)Int.Cl.

H01L 21/027

G03B 27/32

G03F 7/20

(21)Application number : 02-408312

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(22)Date of filing : 27.12.1990

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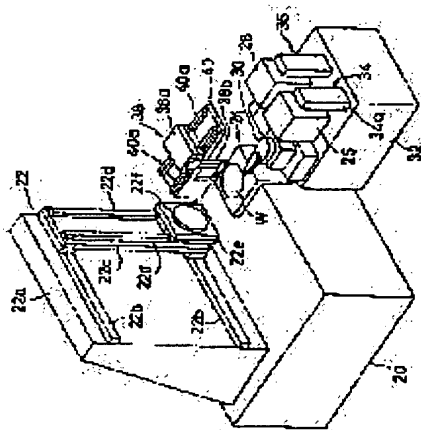
(30)Priority

Priority number : 02184089 Priority date : 13.07.1990 Priority country : JP

## (54) VERTICAL EXPOSURE TRANSFER APPARATUS

(57)Abstract:

PURPOSE: To obtain an apparatus which can utilize most of constituent elements of a wafer automatic exchanger developed for horizontal exposure transfer apparatus use by providing a wafer carrier means and the like which hold a wafer in a horizontal state on a wafer-orienting base, displaces it to a vertical state, and applies it to the wafer chuck plane of a wafer mount disc. CONSTITUTION: A vertical exposure transfer apparatus having a movable base 22e which can move two-dimensionally within a vertical plane and a wafer mount disc 22f fitted to the movable base 22e is provided with a wafer automatic exchanger which comprises a wafer-orienting base 24 which mounts a wafer W in a horizontal state and orients it and a wafer carrier means 38 which holds the horizontal wafer W on the wafer-orienting base 24 to displace it to a vertical state and then applies the wafer W to the wafer chuck



plane of the above-mentioned wafer mount disc 22f. For example, the wafer carrier means 38 should contain a movable element 38a which can move between the first and second positions, a rotary arm 38b fitted to the movable element 38a, and a wafer holder fitted to the free end of a rotary arm 38b.

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#### LEGAL STATUS

[Date of request for examination]

[Date of sending the examiner's decision of rejection]

[Kind of final disposal of application other than the examiner's decision of rejection or application converted registration]

[Date of final disposal for application]

[Patent number]

[Date of registration]

[Number of appeal against examiner's decision of rejection]

[Date of requesting appeal against examiner's decision of rejection]

[Date of extinction of right]